

Docket No. 03500.012395.1

YOSHIHIKO FUKUMOTO

Application No.: 09/429,530

Filed: October 28, 1999

For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE

Examiner: V. Perez Ramos

Group Art Unit: 1765

Date: October 31, 2002

COMMISSIONER FOR PATENTS Washington, D.C. 20231

Sir:

Transmitted herewith is an amendment in the above-identified application.

X No additional fee is required.

The fee has been calculated as shown below

I hereby certify that this correspond nce is deposited with the United States Postal Service: class mail in an envelope addressed to: Commis	as fi rs sion e
of Patents and Trademarks, Washington, D.C.	20231
onOct.31,200 ~	
(Date of Deposit)	
Damond E. Vadnais, Reg no. 52,310	
Name of Attorney for Applicant	
Domod John Q+ 31,2002	
Signature Date of Signature	110

CLAIMS AS AMENDED								
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE		
TOTAL CLAIMS	12	MINUS	34	= 0	x \$9 \$18	.00		
INDEP. CLAIMS	3	MINUS	3	= 0	x \$42 \$84	.00		
Fee for Multi								
·	.00 .00							
Overified Statement claiming small entity status is enclosed, if not filed previously. A check in the amount of \$ is enclosed. Charge \$ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.								

X	Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06 1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
	A check in the amount of \$ to cover the fee for a month extension is enclosed.
X	A check in the amount of \$_180.00\] to cover the Information Disclosure Statement fee is enclosed.
X	Applicant's undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.
	Respectfully submitted,
	Attorney for Applicant Registration No. 52,310

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

CA_MAIN 43060 v 1





IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	Examiner: V. Perez Ramos	
YOSHIHIKO FUKUMOTO	·) :	Group Art Unit: 1765	
Application No.: 09/429,530)	•	•
Filed: October 28, 1999)	70 2	
For: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE)	October 31, 2002	: :
Commissioner for Patents Washington, D.C. 20231		ZWZ	う

<u>AMENDMENT</u>

Sir:

In response to the Office Action dated July 31, 2002 (Paper No. 21), please amend the above-identified application, as follows:

IN THE CLAIMS:

Please cancel Claims 11 to 20, 25 to 27, 30 to 32 and 45 to 54 without prejudice or disclaimer of the subject matter presented therein and without conceding the correctness of their rejection. Please add new Claims 55 to 66 as follows:

deposited with the United States Postal Service as first class mail in an envelope addressed t : Commissioner of Patents and Trademarks, Washington, D.C. 20231 on (Date of Deposit)

Damond E. Vadnais, Reg no. 52,310

Name of Attorney for Applicant

Signature

Date of Signature